

20/ Reg. for rec
V. Bni
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
Shinji TAKEDA et al.) Atty. Docket No.: **TM&K0004**
Serial No. 09/543,247)
Filed: April 5, 2000) Group Art Unit: 2814
For: SEMICONDUCTOR DEVICE AND)
PROCESS FOR FABRICATION) Examiner: David E. Graybill
THEREOF) Date: December 2, 2002

RESPONSE (C) AFTER FINAL

BOX: AFTER FINAL
Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the official Final Office Action dated June 6, 2002 regarding the above captioned application, Applicants make the following remarks.

REMARKS

As an initial matter, Applicants have submitted herewith a certified English translation of Japanese priority document 7-171154, filed July 6, 1995 in Japan. The USPTO has already received a certified copy of the original document (see Office Action Summary, Office Action dated September 10, 2001), and Applicants have properly claimed priority to Japanese document 7-171154, thereby perfecting a priority date of July 6, 1995 for the present application in accordance with 37 C.F.R. 1.55.